



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUKASAWA, Shinji**

Group Art Unit: **2814**

Serial No.: **09/855,590**

Examiner: **T. N. QUACH**

Filed: **May 15, 2001**

**P.T.O. Confirmation No.: 1417**

**FOR: SEMICONDUCTOR DEVICE HAVING A MULTIPLE LAYER WIRING  
STRUCTURE, WIRING METHOD, WIRING DEVICE, AND RECORDING  
MEDIUM**

**AMENDMENT UNDER 37 CFR §1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 10, 2004

Sir:

In response to the Office Action dated **August 10, 2004**, extended to **December 10, 2004** by  
a **one (1)** month Petition for Extension of Time, please amend the above-identified application as  
follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of  
this paper.

**Remarks/Arguments** begin on page 10 of this paper.